

PATENT ASSIGNMENT

Electronic Version v1.1
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
University of Illinois Urbana-Champaign	11/20/2003
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd
Internal Address:	Room 1265
City:	Arlington
State/Country:	VIRGINIA
Postal Code:	22230
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	08378102
CORRESPONDENCE DATA	
Fax Number:	(703)292-9041
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Email:	nsfpatents@nsf.gov
Correspondent Name:	National Science Foundation
Address Line 1:	4201 Wilson Blvd
Address Line 2:	Room 1265
Address Line 4:	Arlington, VIRGINIA 22230
NAME OF SUBMITTER:	Robin Clay Fritsch
Total Attachments: 1 source=40#page1.tif	

License to the United States Government

T94057

Sign and Fax this to (301) 480-0272

Invention Title: Anisotropic (lateral) oxidation and its use in field effect transistors.

Inventor(s): John Dallesasse, Nick Holonyak

U.S. Filing/Issue Date: 1/26/1995

Patent or Application Serial No.: 08/378,102, patent 5,567,980

Grant/Contract Number(s): DMR8920538, ECD8943166

Foreign Applications filed/intended in (countries): _____

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

1. The nonexclusive, nontransferable, irrevocable, paid-up license to practice or have practiced for or on behalf of the United States the invention described in any patent application and in any and all divisions, continuations, and continuations in part, and in any and all patents and re-issues granted thereon throughout the world; and
2. All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations that are applicable to the award.

The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 20 day of November, 20 03.

By Stephen K. Rugg
(Name of Grantee/Contractor Official)

Stephen K. Rugg
(Signature)

Title Vice President for Administration, Comptroller

For UNIVERSITY OF ILLINOIS URBANA-CHAMPAIGN
(Grantee/Contractor Organization)

At 506 S. Wright Street Urbana, IL 61801 US
(Business Address)